

## PGM-Series

Plane Grating Monographs

Straight by Design

Imaging Correction<sup>PLUS</sup> Technology Wide spectral range

True Flat Field

EUV Spectroscop

Monograph Design



# Monographs to explore the 1–175 nm spectral range

# Variable Line Spacing Gratings

Our PGMs use VLS gratings combined with toroidal mirrors. The combination of these two optics disperses and refocuces the light from the entrance slit onto the exit focal plane of the monograph.

The wavelength selection and the scanning are obtained through a simple rotation of the grating.

The groove spacing of VLS gratings and the parameters of the associated toroidal mirror are both optimized with our Imaging Correction<sup>PLUS</sup> Technology that produces high quality images with minimum astigmatism and coma over a large spectral range and even at high numerical aperture.

The VLS grating grooves are no longer straight and parallel, but instead correspond to confocal hyperboloids or ellipsoids. Optimizing the position, angles and arm lengths of the two recording beams provides the optical designer with the degrees of freedom necessary to minimize aberrations.



The PGM (Plane Grating Monograph) series are especially designed for analyzing Extreme UV (EUV) to Far UV (FUV) as a monochromator (slit-slit) or spectrograph (slit-CCD port).



Instead of having a fixed spherical grating and the exit port rotating on the Rowland circle like most of the other common designs, our PGM is straight (the entrance and exit arm are parallel) and both entrance and exit ports are fixed, making our compact PGM a very easy solution to integrate into your existing setup.

#### **Applications**

- High Harmonic Generation
- Plasma Physics Study
- VUV Laser Analysis
- Study of High Harmonics Filters
- FUV/EUV Spectroscopy
- XPS
- EUV Reflectometry

#### **Features**

- Imaging Correction Plus Technology
- On Axial optical design
- Choice of master or replica gratings
- Kinematic Grating Mount or three gratings slider
- CCD port mounted on X table
- Patented layout

#### Benefits

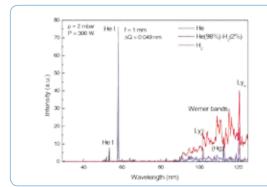
- The best image on your CCD over 25 mm focal plane
- Less room needed and easy to align
- Optimize damage threshold or cost
- Interchangeable gratings
- In vacuum focus adjustment
- Use grazing incidence angles onto the optics and normal incidence for CCD illumination

#### A corrected grating for original optical layout

#### A versatile and interchangeable exit port

Based on our unique optical design coupling a toroidal mirror and an aberration corrected plane grating, the PGM can be used both as a monochromator (with an exit slit) or as a flat field spectrograph (with CCD port).

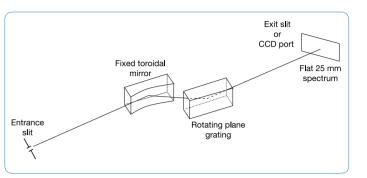
Flat-field focus plane being always perpendicular to the exit axis of the instrument, the CCD receives the maximum energy dispersed by the grating over the whole spectral range of analysis. This is made possible thanks to an original optical layout: a rotating plane grating and a fixed toroïdal mirror which have been coupled to enhance the image at the exit port of the instrument with our Imaging Correction Plus Technology.

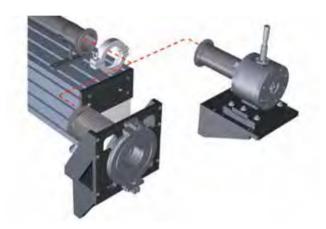


UV emission of H., plasma at different microwave powers.

Data courtesy of F. M. Dias (IST, Eisboa) et al. (30th ICPIG, August 28th – September 2nd 2011,

Belfast, Northern Ireland, UK)





Exit ports of the PGM-PGS are easily interchangeable from slit to CCD

#### Gratings available

| Model   | Gratings    |                    | Spectral Range<br>Spectrograph Mode<br>Monochromator Mode |                           | Exit Dispersion                          | Resolution**    |
|---------|-------------|--------------------|---|---------------------------|--|-----------------|
|         | Part Number | Density<br>(gr/mm) | nm  | eV                        |  | (FWHM in nm)    |
|         | 544 01 010  | 1800               | 1 - 25<br>3.5 - 16  | 50-1240<br>78-354         | 0.4 nm/mm at 3.5 nm, 0.7 nm/mm at 16 nm  | 0.10 at 13 nm   |
| PGM200  | 544 02 010* | 800                | 2 - 56<br>6.5 - 35  | 22 - 620<br>36 - 190      | 0.9 nm/mm at 3.5 nm, 1.5 nm/mm at 35 nm  | 0.14 at 33.5 nm |
|         | 544 06 010* | 450                | 3 - 100<br>10.5 - 63                                      | 12 - 400<br>20 - 120      | 1.6 nm/mm at 10.5 nm, 2.6 nm/mm at 63 nm | 0.15 at 10.5 nm |
| PGM1000 | 544 02 130* | 1800               | 2-35<br>8 - 35  | 35 - 620<br>35 - 155      | 0.09 nm/mm at 8 nm, 0.03 nm/mm at 35 nm  | 0.008 at 8 nm   |
|         | 544 01 030* | 550                | 7-126<br>30 - 125   | 10 -180<br><i>10 - 41</i> | 0.3 nm/mm at 30 nm, 0.07 nm/mm at 125 nm | 0.03 at 30 nm   |

<sup>\*</sup> Gratings are available in master or replica version

#### **Options**

- Ultra High Vacuum (UHV, 10<sup>-9</sup> mbar) version
- Slider for grating change under vacuum

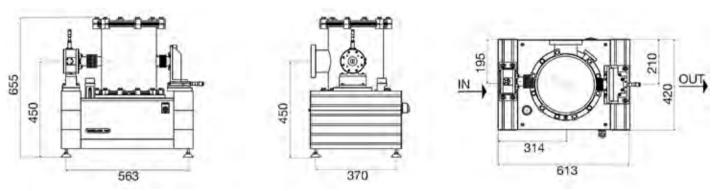
#### Accessories

- EUV/UV Light Sources
- CCD detectors
- Single channel detection
- Mirror chambers

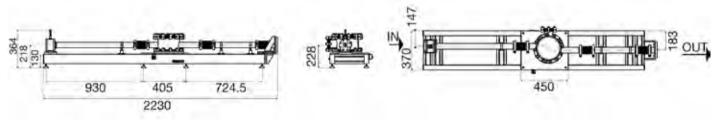
<sup>\*\*</sup> using 10 µm x 2 mm slits

### **P5** Specifications

|                 | PGM200  | PGM1000  |  |  |  |  |
|-----------------|---|----------|--|--|--|--|
| Optical design  | Toroidal mirror and plane VLS grating                                     |          |  |  |  |  |
| Focal length    | 251 mm  | 1090 mm  |  |  |  |  |
| Aperture        | f/16  | f/50     |  |  |  |  |
| Optic coating   | Pt or A   | Pt or Au |  |  |  |  |
| Deviation angle | 165°  | 156°     |  |  |  |  |
| Drive           | Sine arm  |          |  |  |  |  |
| Vacuum          | 10 <sup>-6</sup> mbar (HV version) or 10 <sup>-9</sup> mbar (UHV version) |          |  |  |  |  |
| Pumping flange  | DN63 LF   |          |  |  |  |  |
| Entrance port   | Micrometric slit (10 µm to 2 mm)  |          |  |  |  |  |
| Entrance flange | DN40 KF   |          |  |  |  |  |
| Exit port       | Micrometric slit (10 µm to 2 mm) or adjustable CCD port                   |          |  |  |  |  |
| Exit flange     | DN40KF for slit version, DN100CF for CCD version                          |          |  |  |  |  |
| Software        | HORIBA Scientific software  |          |  |  |  |  |
| PC Interface    | RS232 - USB2  |          |  |  |  |  |



PGM200 in HV version, three gratings on slider, in spectrograph mode



PGM1000 in HV version, in single grating configuration, in spectrograph mode

Dimensions may change depending on the selected options

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